

**EXPEDITED PROCEDURE – GROUP ART UNIT 2619**

**RESPONSE UNDER 37 C.F.R. §1.116**

U.S. Serial No. 10/821,016

Patent/Docket No. 2003-0372 / 24061.93

Response to Final Office Action dated April 15, 2009

Customer No. 42717

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant:	Hsiao-Wen Wan, et al.	§	Docket No.:	24061.93 / 2003-0372
Serial No.:	10/821,016	§	Examiner:	Peling A. Shaw
Filed:	April 8, 2004	§	Art Unit:	2444
For:	Method for Circulating a Report in a Semiconductor Manufacturing Environment	§	Conf. No.:	9310

**RESPONSE TO FINAL OFFICE ACTION DATED APRIL 15, 2009**

Mail Stop: AF  
Commissioner For Patents  
PO Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

This paper is submitted in response to the Office action dated April 15, 2009, in connection with the above-noted application. No fees, including extension of time fees, are believed necessary for consideration of the present paper. However, if any fees, including extension of time fees, are necessary, the extension of time is hereby requested, and the Commissioner is hereby authorized to charge any fees, including those for the extension of time, to Haynes and Boone, LLP's Deposit Account No. 08-1394

**Amendments to the Claims** are reflected in the listing of claims, which begins on **page 2** of this paper.

**Remarks** begin on **page 6** of this paper.